

Application No: 10/520,232
Amendment A
Reply to Office Action Dated 07/26/2007

Attorney Docket No: 3926.127

ABSTRACT OF THE DISCLOSURE

The method serves for cleaning at least one surface (12) of a component (10) using a cleaning device (14), the surface (12) of the component being cleaned by means of a cleaning head (18) which can be moved by a positioning device (16), while forming a contact pressure of the cleaning head (18) on the component (10). It is provided here that the positioning device (16) has a coarse positioning system (20) and a fine positioning system (22), the cleaning head (18) being moved in a force-controlled manner by means of the fine positioning system (22) in at least one direction of movement (24, 26, 28, 30, 32, 34). Furthermore, a corresponding cleaning device for implementing the method is provided.